

1	Application/Control No.	Applicant(s)/Patent under Reexamination	
	09/483,386	LI-WEN CHEN	
E	Examiner	Art Unit	
E	Ella Colbert	3624	

SEARCHED					
Class	Subclass	Date	Examiner		
707	1,10,102	8/15/2005	EC		
	100,101				
	104.1,200				
	201,206				
705	1,5,7,14				
	16,26,28				
	30,35,39	·			
	10, 44				
717	5,102,104				
	105		:		
706	52				
			-		

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
707	1010,102	8/15/05	EC			
105	15718.141	6				
6	74830,35	39				
717	5,102,104/	8/15/05	EC			
706	52	oji 4°				

	SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR		
EIC Search	7/13/2005	EC		
IEEE, Internet, and ACM Search	7/6/2005			
WEST Search	7/19/2005	•		
WEST Search	8/15/2005			
Consulted With Primary Alford Kindred Art Unit 2172, class 707	7/25/2005			
Consulted With SPRE Bob Wienhardt	8/9/2005			
		,		